

Appl. No. : 10/618,900
Filed : July 14, 2003

SUMMARY OF INTERVIEW

Applicant wishes to thank Examiner Rudy Zervigon for the courteous telephone interview extended to their representative that was conducted on July 14, 2006.

Exhibits or demonstrations shown

None.

Identification of Prior Art Discussed

Kajita (US 5,653,634) and Hayakawa (US 5,447,568) were discussed.

Proposed Amendments

Applicant's representative suggested inserting the word "exclusively" in the sentence "said vaporization surface having pores distributed in the vicinity of its periphery."

Principal Arguments and Other Matters

Hayakawa's plate is a gas ratifying plate, not an evaporation plate.

Kajita's plate is an evaporation plate but is not disposed between the ceiling of the chamber and the shower plate. Further, Kajita's plate has no pore.

Hayakawa's gas ratifying plate could not be replaced with Kajita's evaporation pate because of their different functionality.

Even if the teachings of Hayakawa and Kajita are combined, the combination still could not lead to the claimed invention.

Results of Interview

The Examiner disagreed with the representative's arguments because Hayakawa's plate could function as an evaporation plate when a gas condenses on its surface even if Hayakawa is silent about the possibility, and Hayakawa and Kajita could at least conceptually (if not structurally) be combined.

The Examiner agreed that the word "exclusively" could distinguish the claimed structures from the prior art.